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CLAIMS:

What is claimed is:

1 1. A reduced sensitivity spin valve sensor apparatus,

2 comprising:

a spin valve sensor; and

a pair of magnetic shields, wherein a spacing

5 between the spin valve sensor and each magnetic shield of

6 the pair of magnetic shields is reduced relative to

7 standard spin valve sensor apparatus to thereby reduce a

8 flux injection efficiency of the spin valve sensor.

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- 1 2. The reduced sensitivity spin valve sensor apparatus
- 2 of claim 1, wherein the spacing between the spin valve
- 3 sensor and each magnetic shield is reduced by decreasing
- 4 a thickness of an insulating layer between the spin valve
- 5 sensor and the magnetic shields.

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- 1 3. A spin valve sensor apparatus, comprising:
- 2 a first spin valve sensor;
- 3 a second spin valve sensor; and
- at least one flux guide, wherein a flux generated by
- 5 the at least one flux guide is shared between the first
- 6 spin valve sensor and the second spin valve sensor to
- 7 thereby reduce a sensitivity of the spin valve sensor
- 8 apparatus.

- 1 4. The spin valve sensor apparatus of claim 3, wherein
- 2 the sharing of the flux between the first spin valve

- 3 sensor and the second spin valve sensor reduces a flux
- 4 injection efficiency of the spin valve sensor apparatus.

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- 1 5. The spin valve sensor apparatus of claim 3, wherein
- 2 the at least one flux guide includes a top flux guide and
- 3 a bottom flux guide.

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- 1 6. The spin valve sensor apparatus of claim 5, wherein
- 2 the top flux guide is positioned between the first spin
- 3 valve sensor and the second spin valve sensor, and the
- 4 bottom flux guide is positioned nearest a side of the
- 5 second spin valve sensor that is furthest away from the
- 6 first spin valve sensor.

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- 1 7. The spin valve sensor apparatus of claim 3, further
- 2 comprising planars, wherein the second spin valve sensor
- 3 is positioned on the planars.

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- 1 8. A method of making a reduced sensitivity spin valve
- 2 sensor apparatus, comprising:
- 3 providing a spin valve sensor; and
- 4 providing a pair of magnetic shields, wherein a
- 5 spacing between the spin valve sensor and each magnetic
- 6 shield of the pair of magnetic shields is reduced
- 7 relative to standard spin valve sensor apparatus to
- 8 thereby reduce a flux injection efficiency of the spin
- 9 valve sensor.

- 1 9. The method of making a reduced sensitivity spin
- 2 valve sensor apparatus of claim 8, wherein the spacing

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- 3 between the spin valve sensor and each magnetic shield is
- 4 reduced by decreasing a thickness of an insulating layer
- 5 between the spin valve sensor and the magnetic shields.

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- 1 10. A method of making a spin valve sensor apparatus,
- 2 comprising:
- 3 providing a first spin valve sensor;
- 4 providing a second spin valve sensor; and
- 5 providing at least one flux guide, wherein a flux
- 6 generated by the at least one flux guide is shared
- 7 between the first spin valve sensor and the second spin
- 8 valve sensor to thereby reduce a sensitivity of the spin
- 9 valve sensor apparatus.

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- 1 11. The method of making a spin valve sensor apparatus
- 2 of claim 10, wherein the sharing of the flux between the
- 3 first spin valve sensor and the second spin valve sensor
- 4 reduces a flux injection efficiency of the spin valve
- 5 sensor apparatus.

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- 1 12. The method of making a spin valve sensor apparatus
- 2 of claim 10, wherein providing the at least one flux
- 3 guide includes providing a top flux guide and a bottom
- 4 flux guide.

- 1 13. The method of making a spin valve sensor apparatus
- 2 of claim 12, wherein providing the top flux guide
- 3 includes positioning the top flux guide between the first
- 4 spin valve sensor and the second spin valve sensor, and
- 5 providing the bottom flux guide includes positioning the

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- 6 bottom flux guide nearest a side of the second spin valve
- 7 sensor that is furthest away from the first spin valve
- 8 sensor.

- 1 14. The method of making a spin valve sensor apparatus
- 2 of claim 3, further comprising providing planars, wherein
- 3 providing the second spin valve sensor includes
- 4 positioning the second spin valve sensor on the planars